

<b>Notice of References Cited</b>	Application/Control No. 10/763,858	Applicant(s)/Patent Under Reexamination ITO, HARUKI	
	Examiner Cheung Lee	Art Unit 2812	Page 1 of 1

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	B	US-6,713,859	03-2004	Ma, Qing	257/687
	C	US-			
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	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Stanley Wolf and Richard Tauber, "Silicon Processing for the VLSI Era" Vol. 1, Lattice Press 1986, Pages 407-409
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.